		· · · · · · · · · · · · · · · · · · ·	
Notice of Allowability	Application No.	Applicant(s)	
	10/614,512	CHOI, JAE SUNG	
	Examiner	Art Unit	J
	Lynne A. Gurley	2812	Jan
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313 1. This communication is responsive to the amendment and the second secon	(OR REMAINS) CLOSED in this apply or other appropriate communication IGHTS. This application is subject to 3 and MPEP 1308.	olication. If not include will be mailed in due of withdrawal from issue	d ourse. THIS
2. ⊠ The allowed claim(s) is/are <u>1-7</u> .			
3. $igotimes$ The drawings filed on <u>21 April 2004</u> are accepted by the E	xaminer.		
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a)			
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal P 6. ☑ Interview Summary Paper No./Mail Dat 7. ☑ Examiner's Amendr 8. ☑ Examiner's Stateme 9. ☐ Other	(PTO-413), de <u>6/8/04</u> nent/Comment	,
WANT A STURLEY			
	PRIMAG	Y PATENT PRO	

TC 2800, AU 2812

Art Unit: 2812

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Yoon S. Ham on 6/9/04.

The application has been amended as follows:

In claim 1, line 20, --to form said dual damascene pattern—has been inserted after "hardened photoresist pattern", before ".".

Reasons For Allowance

2. The following is an examiner's statement of reasons for allowance: The closest prior art of record, Kye (US 6,602, 794), found during the updated search, fails to teach, either alone or in combination, the steps of the claimed invention, in particular, the claimed steps in combination with the formation of a dual damascene pattern.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Application/Control Number: 10/614,512 Page 3

Art Unit: 2812

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lynne A. Gurley whose telephone number is 571-272-1670. The examiner can normally be reached on M-F 7:30-4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John Niebling can be reached on 571-272-1679. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Lynne A. Gurley

Primary Patent Examiner

TC 2800, AU 2812

LAG

June 9, 2004